

NOTES:

1. SUBSTRATE:
FUSED SILICA

2. CLEAR APERTURE AND COATING APERTURE ARE
CENTERED ON SURFACE

3. COATING (APPLY ACROSS CLEAR APERTURE)

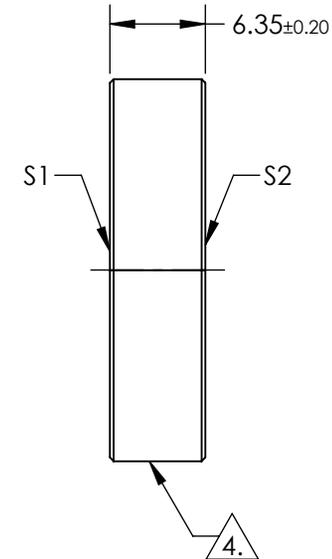
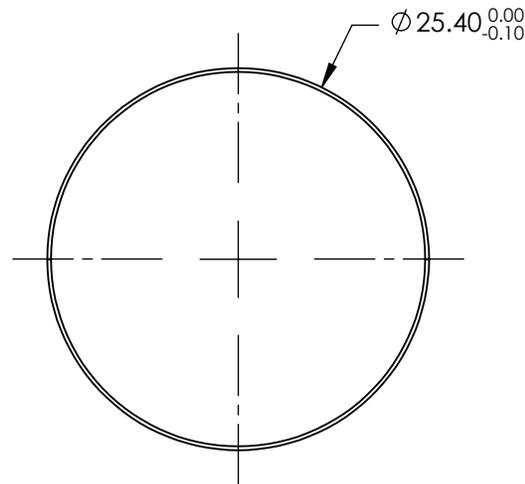
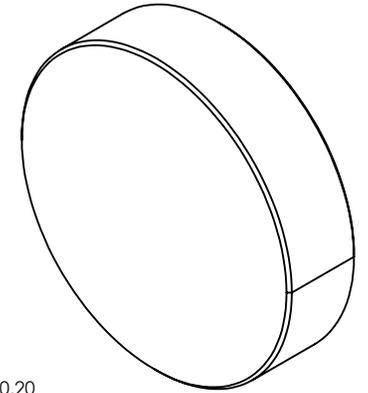
S1:R(AVG) > 99.0% FROM 260-267nm AT 45° AOI
DAMAGE THRESHOLD,
PULSED: 2.5 J/cm², 20ns, 20 Hz @ 266 nm

S2: NONE

4. FINE GRIND SURFACE

5. SURFACE FLATNESS AND SURFACE QUALITY
SPECIFICATION APPLY ACROSS CLEAR APERTURE

6. ROHS COMPLIANT



**FOR INFORMATION ONLY:
DO NOT MANUFACTURE
PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2
SHAPE	PLANO	PLANO
SURFACE FLATNESS	0.1 WAVE	N/A
SURFACE QUALITY	10-5	N/A
CLEAR APERTURE	$\varnothing 21.59$	$\varnothing 21.59$
BEVEL	PROTECTED AS NEEDED	PROTECTED AS NEEDED



ALL DIMS IN

mm

EO® Edmund Optics®

TITLE

25.4mm Dia. 261.4nm 45°, Nd:YAG Laser Line
Mirror

DWG NO

19736

SHEET
1 OF 1